

FIG. 1

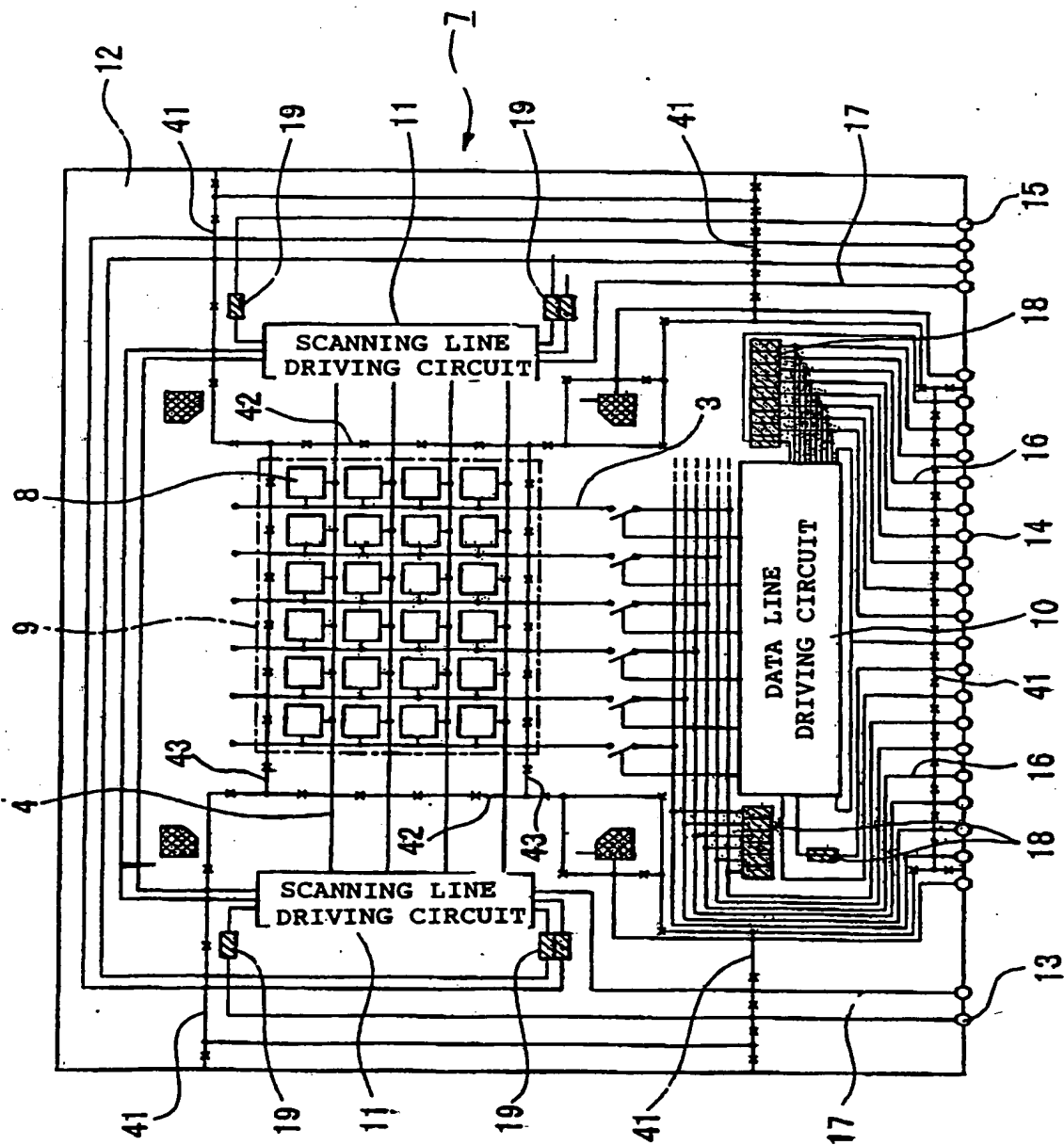


FIG. 2

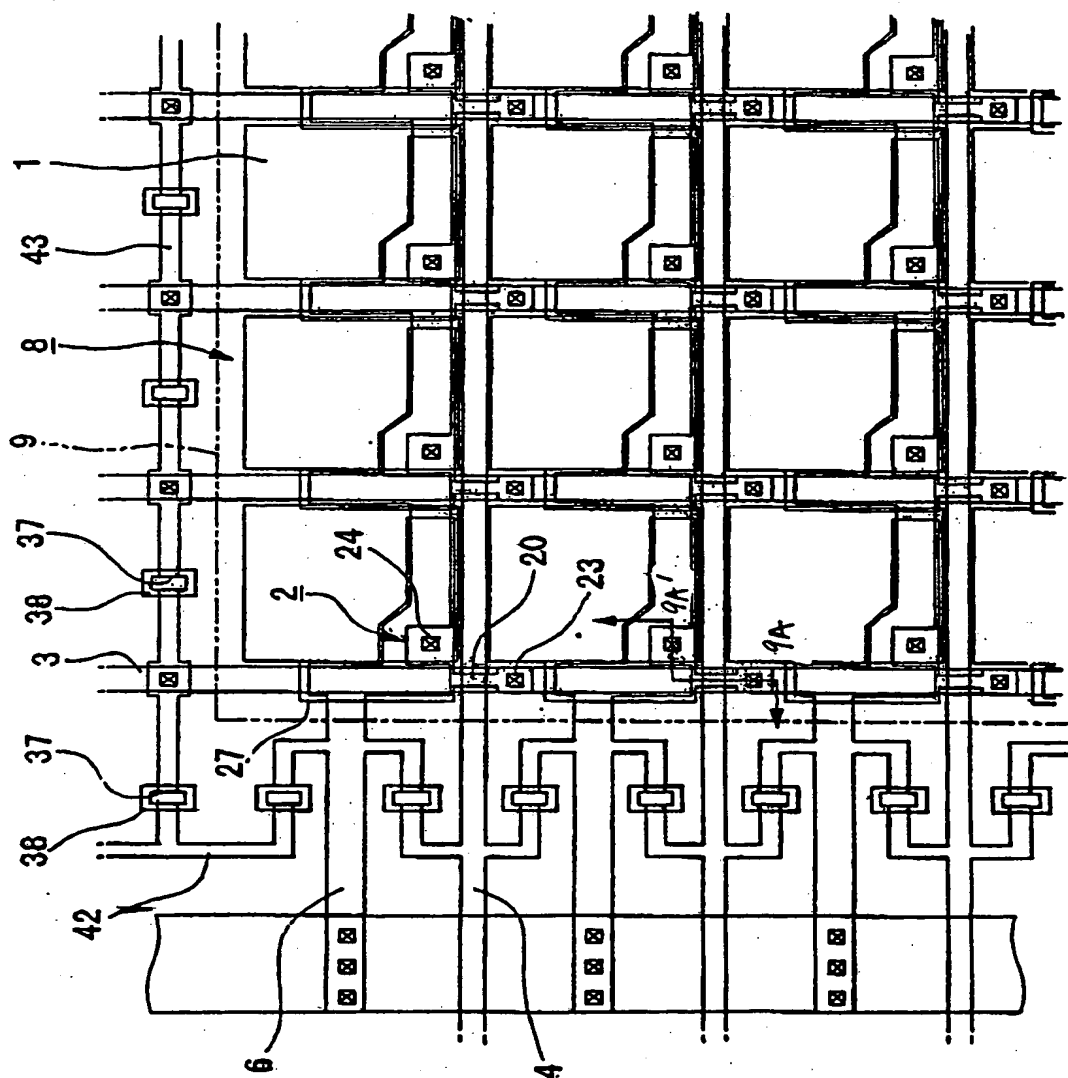


FIG. 3

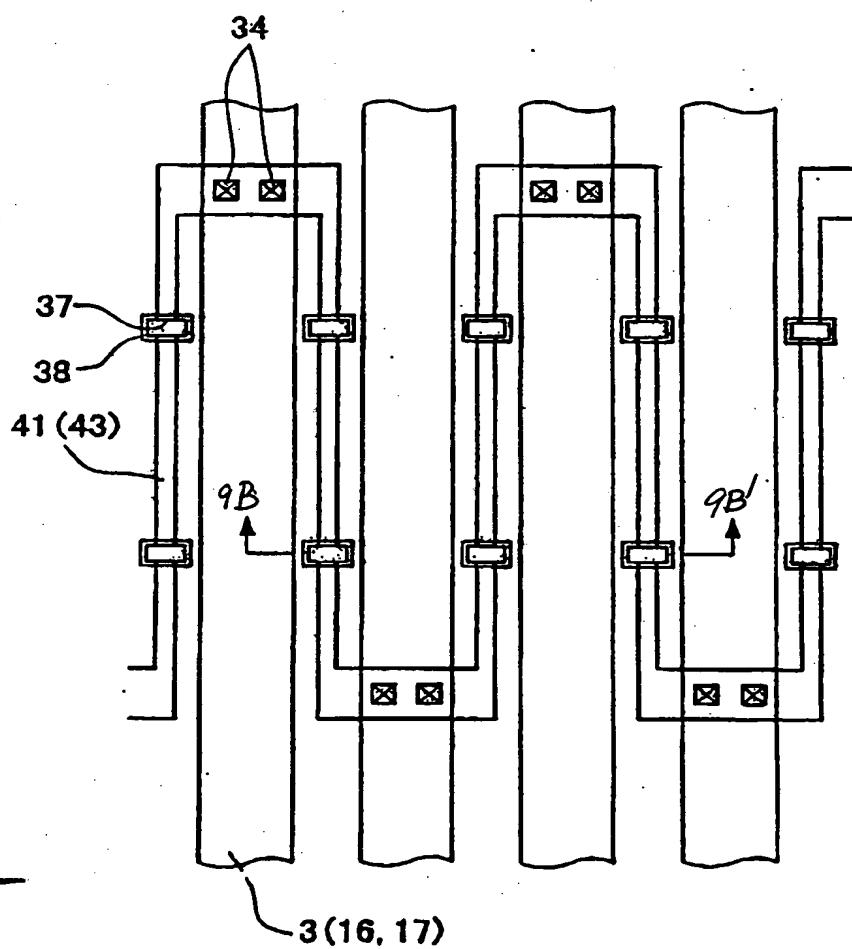


FIG. 4

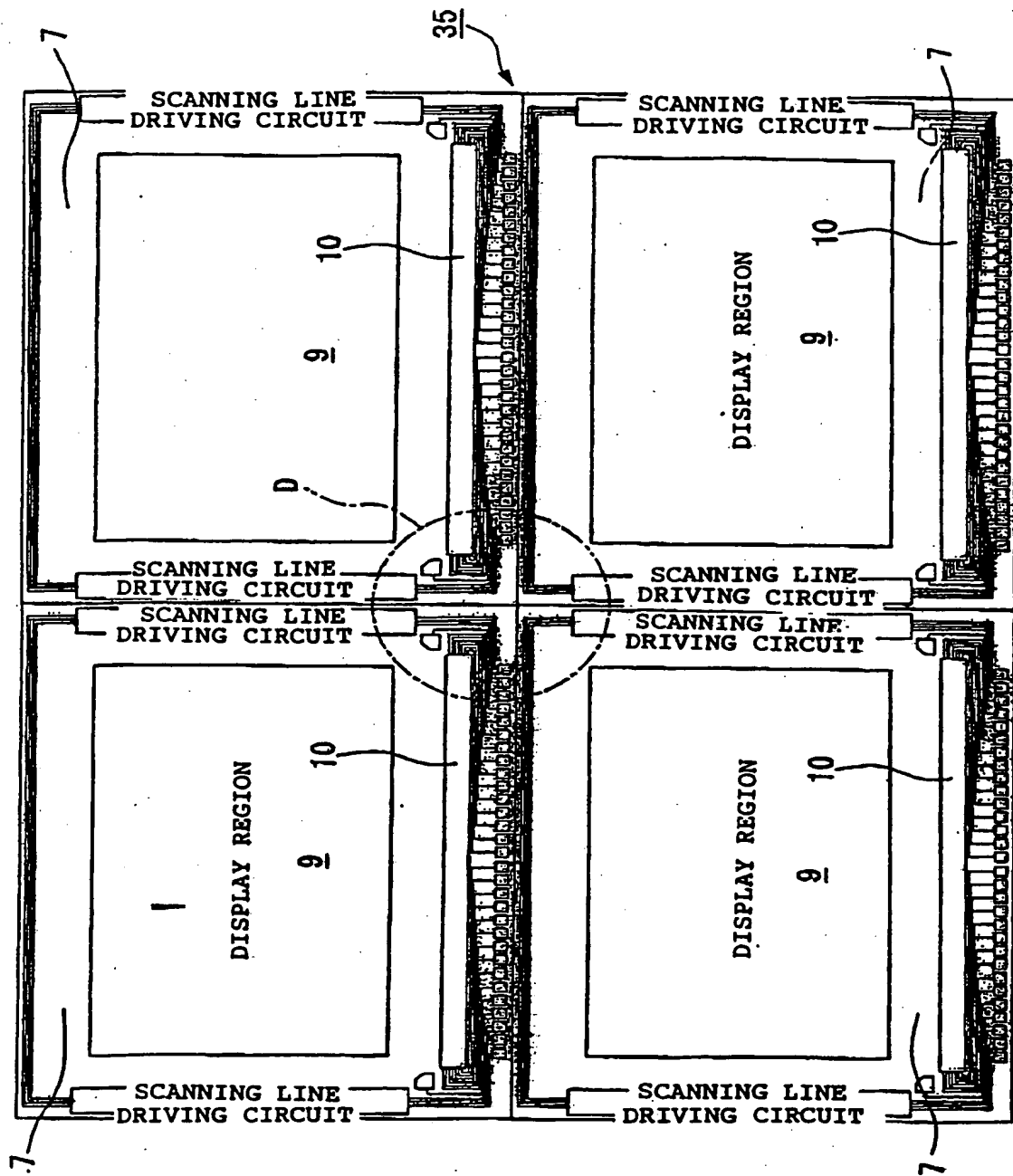


FIG. 6

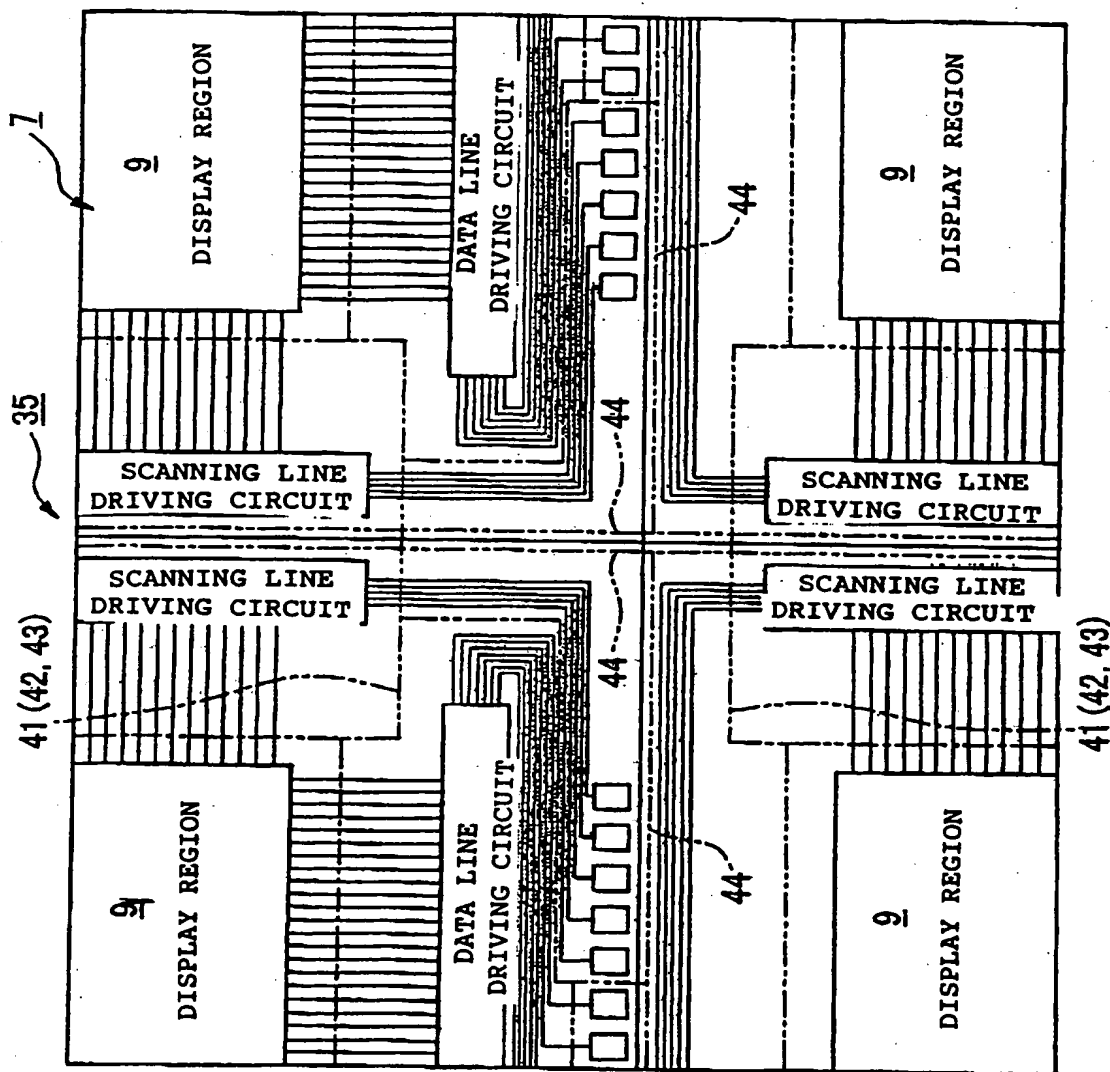


FIG. 7

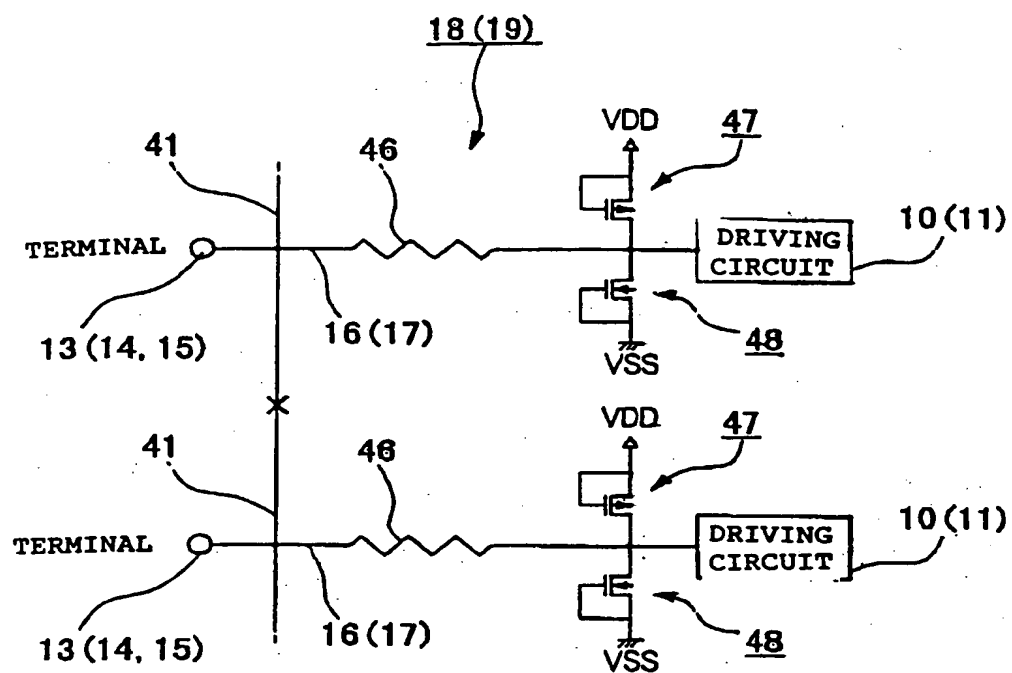
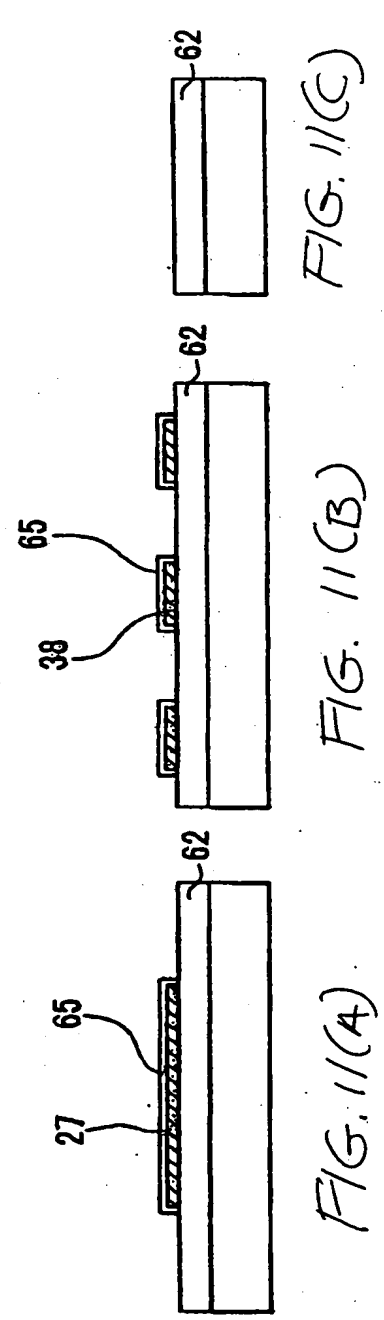
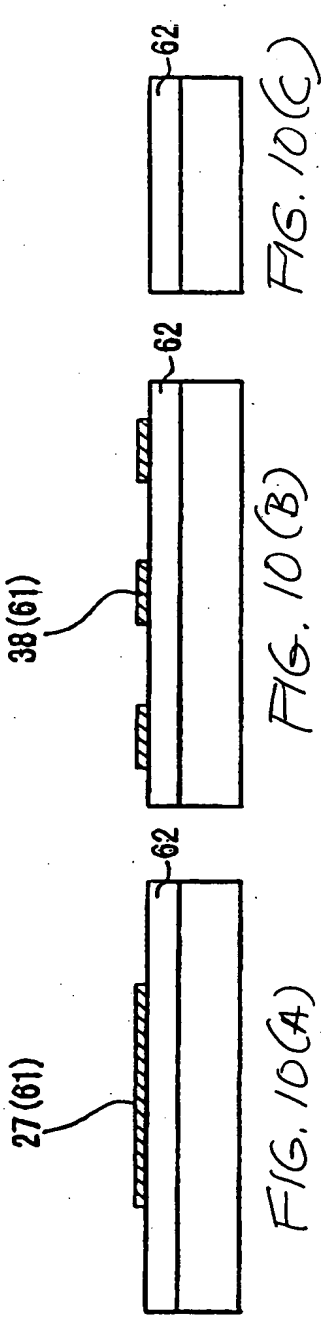
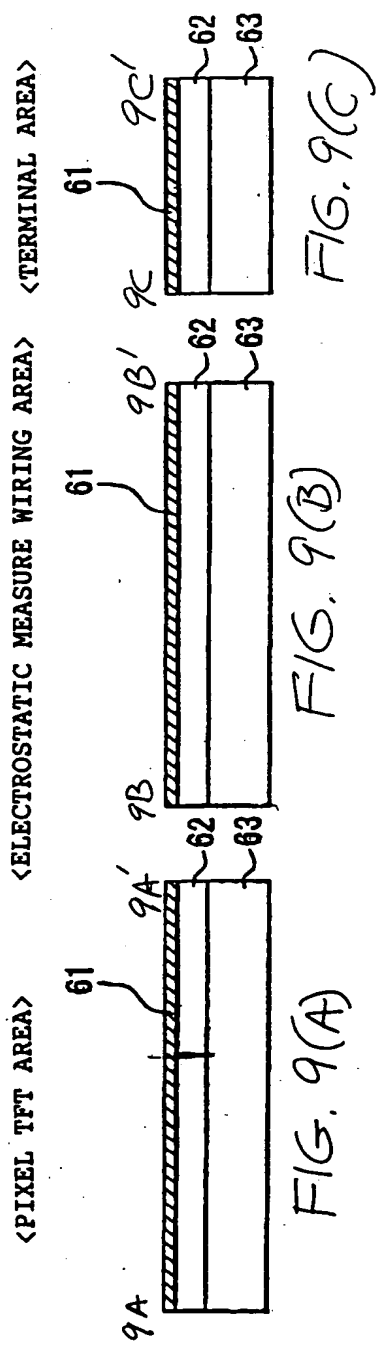
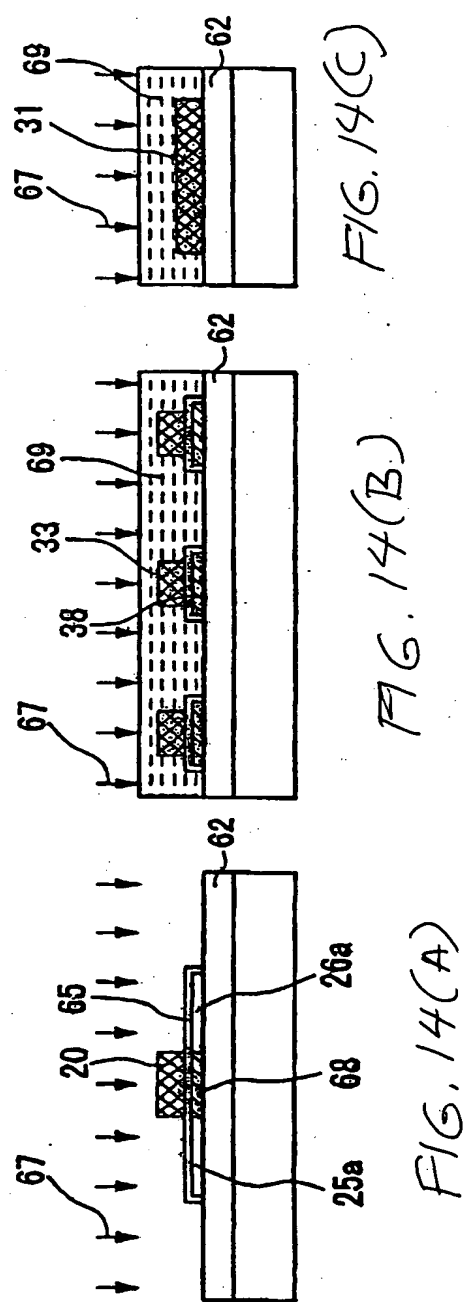
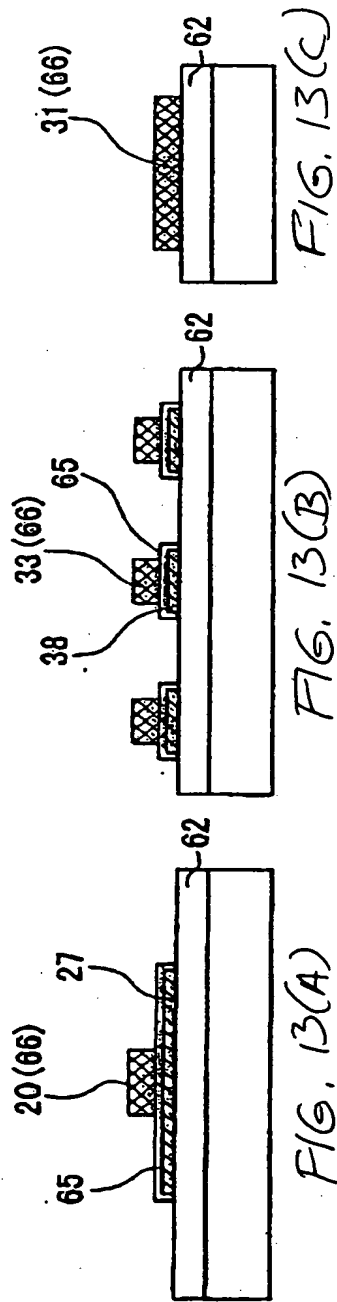
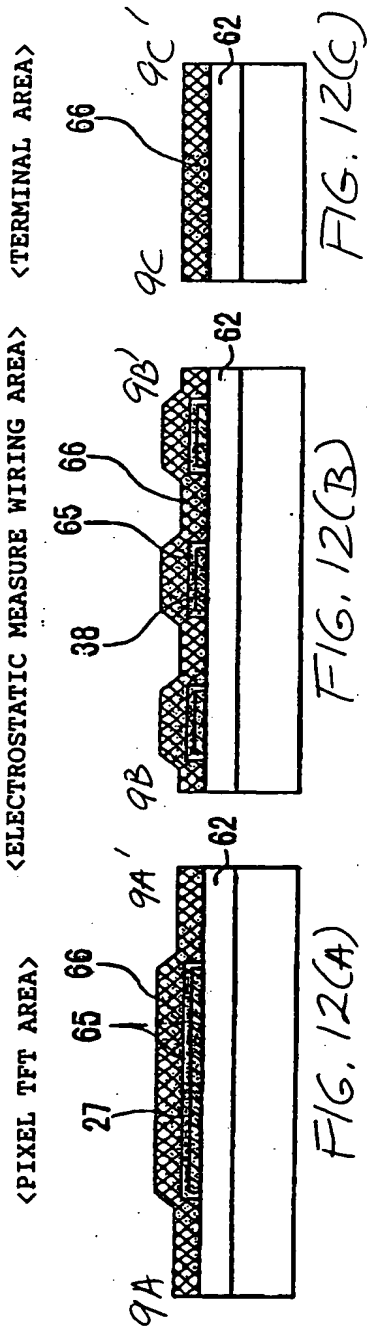


FIG. 8





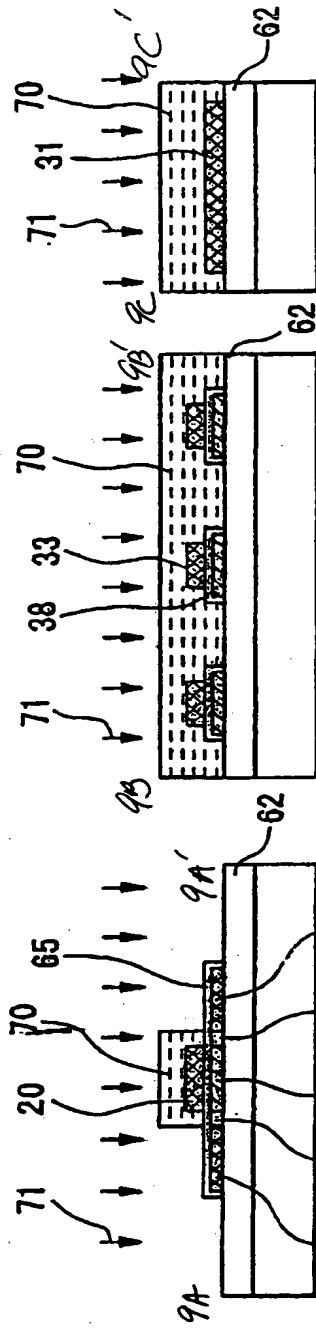


FIG. 15(A)

FIG. 15(B)

FIG. 15(C)

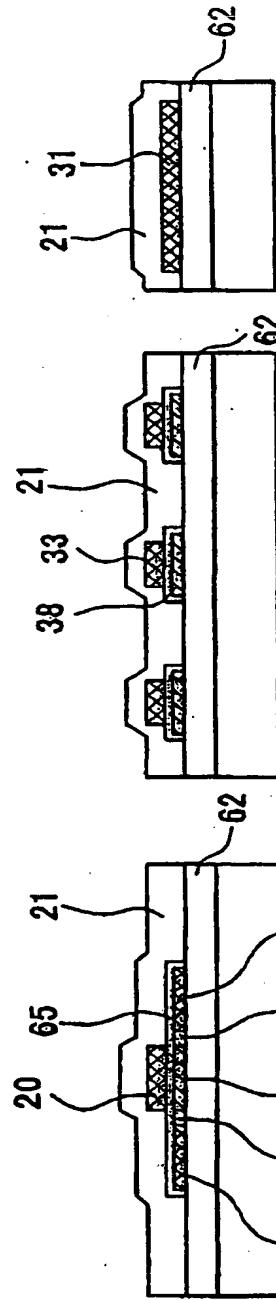
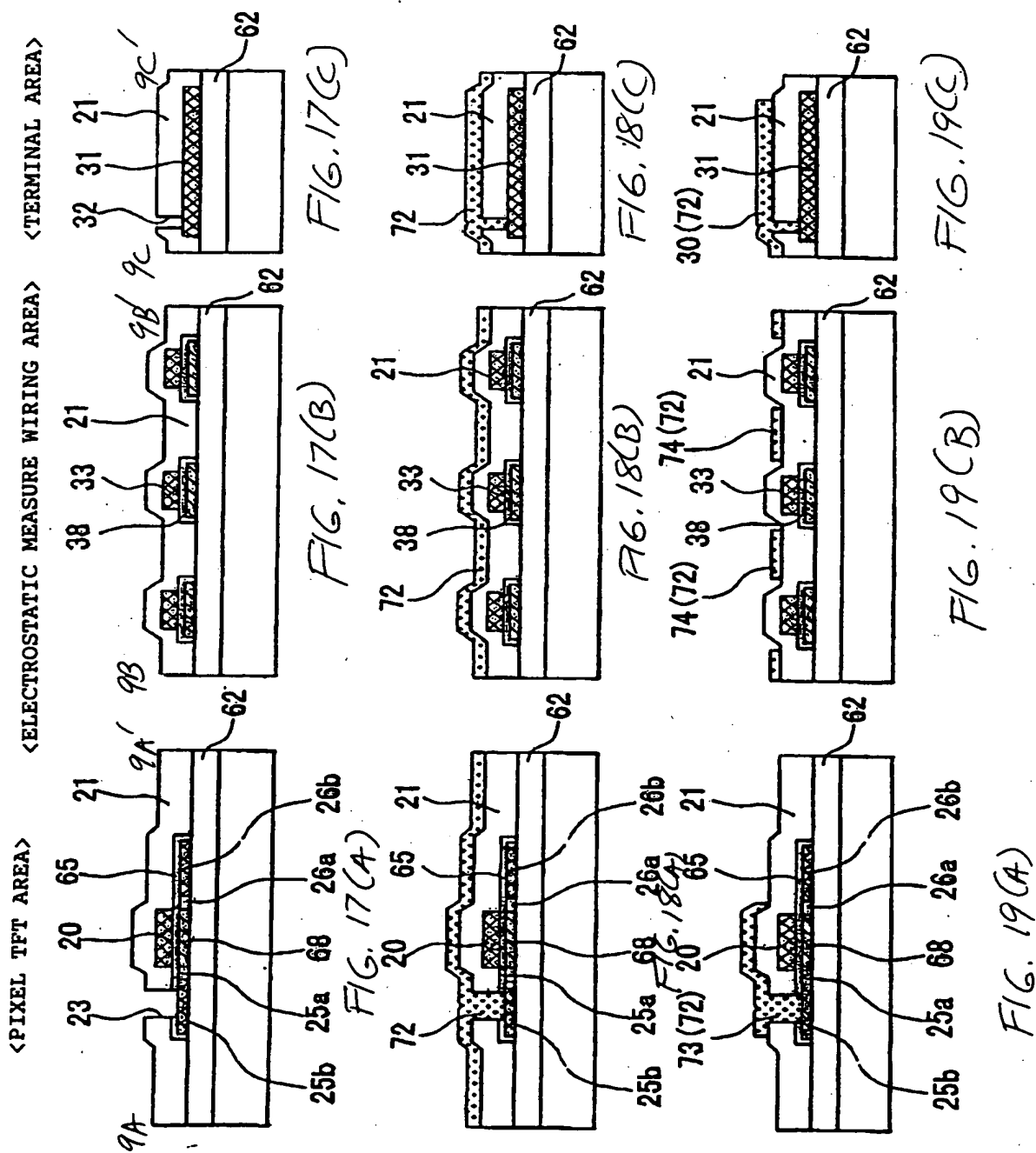
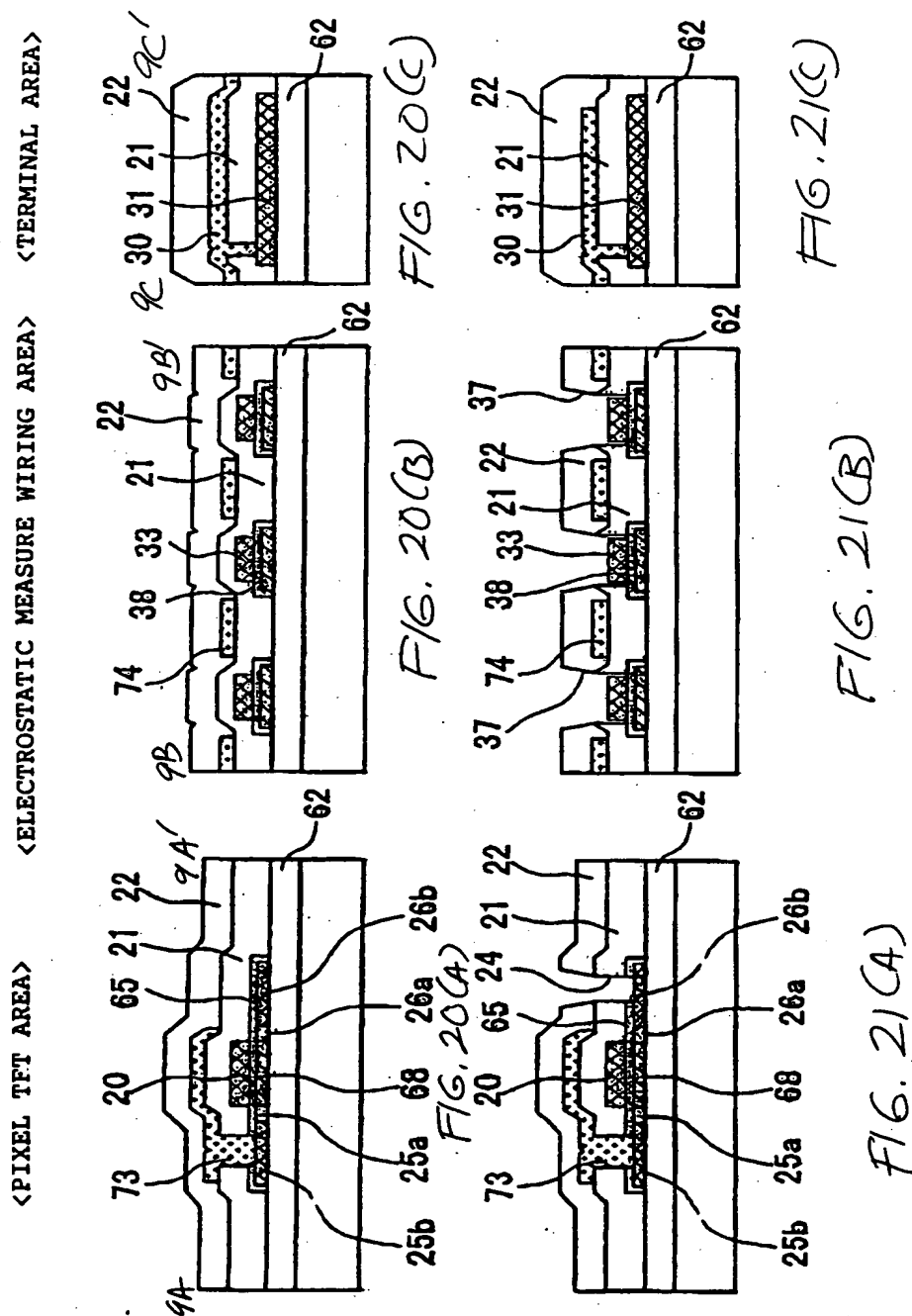


FIG. 16(A)

FIG. 16(B)

FIG. 16(C)





<PIXEL TFT AREA> <ELECTROSTATIC MEASURE WIRING AREA> <TERMINAL AREA>

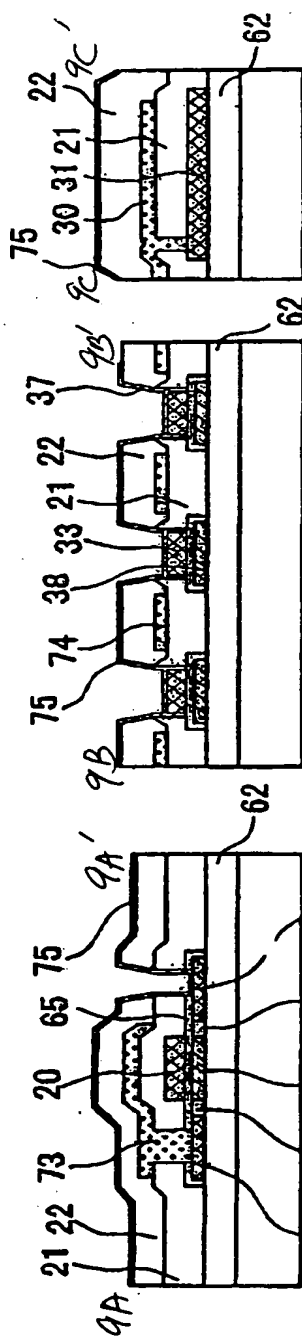


FIG. 22(A)

FIG. 22(B)

FIG. 22(C)

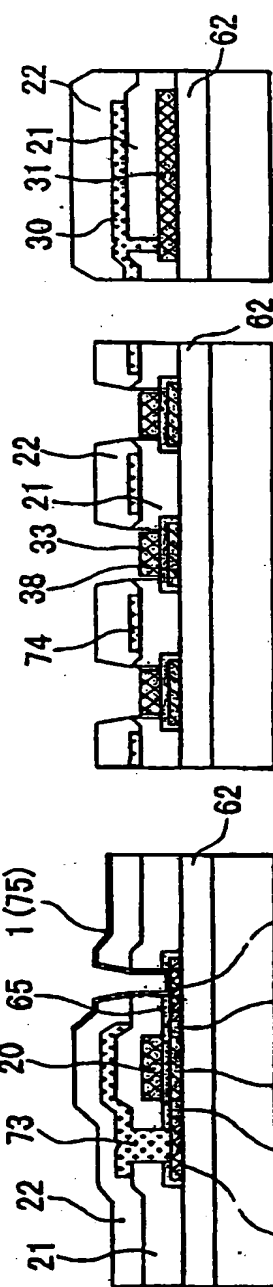
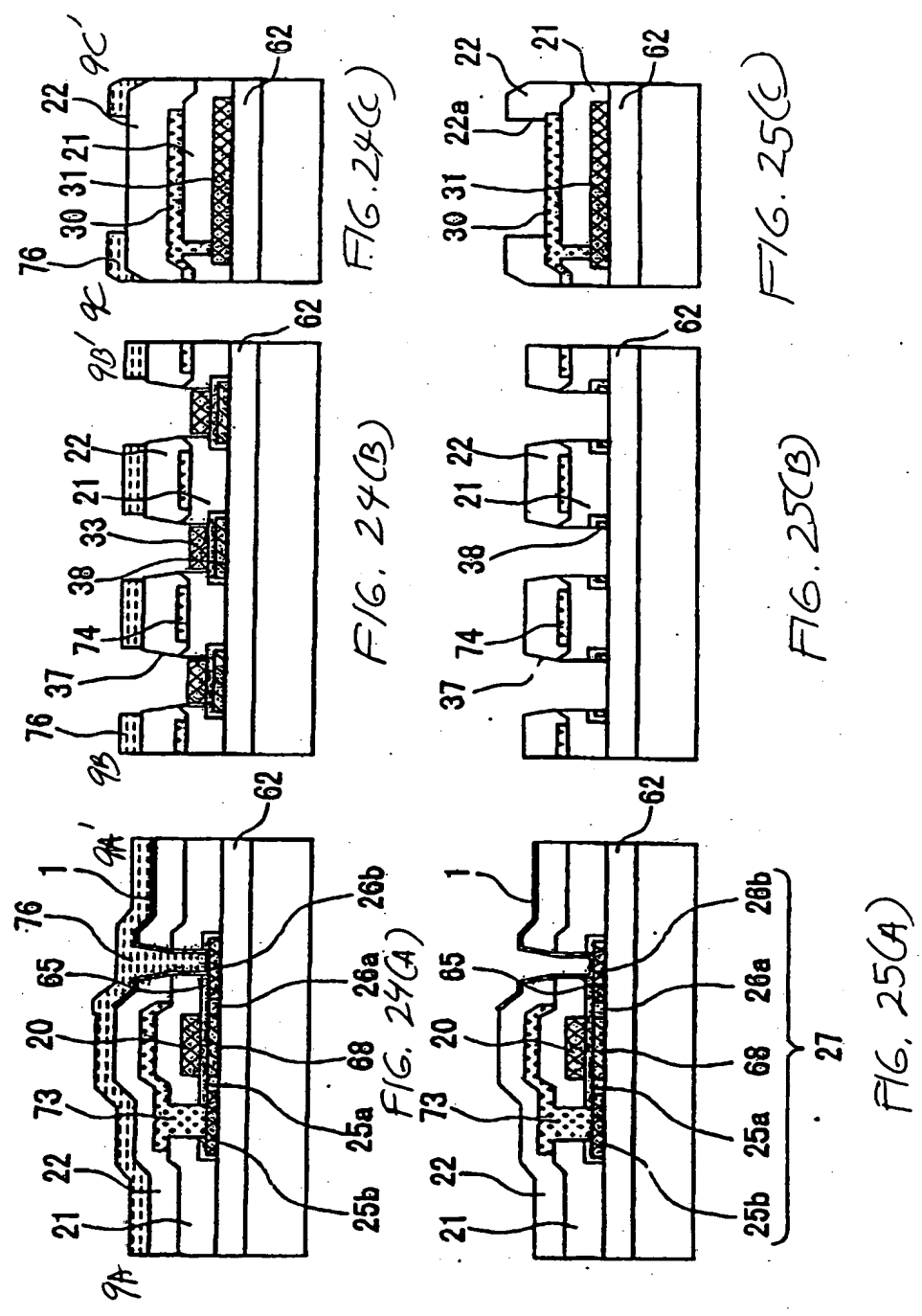


FIG. 23(A)

FIG. 23(B)

FIG. 23(C)

<PIXEL TFT AREA> <ELECTROSTATIC MEASURE WIRING AREA> <TERMINAL AREA>



1

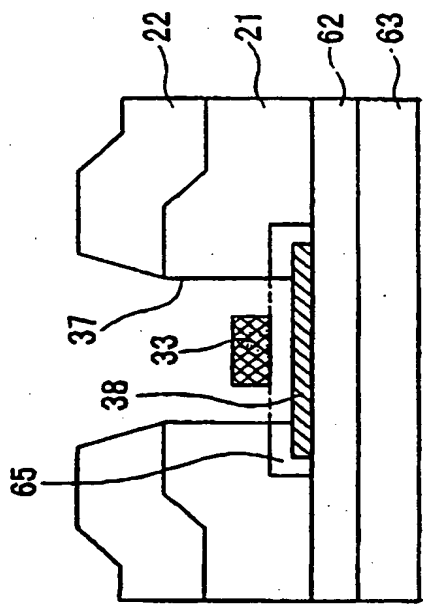


FIG. 26(B)

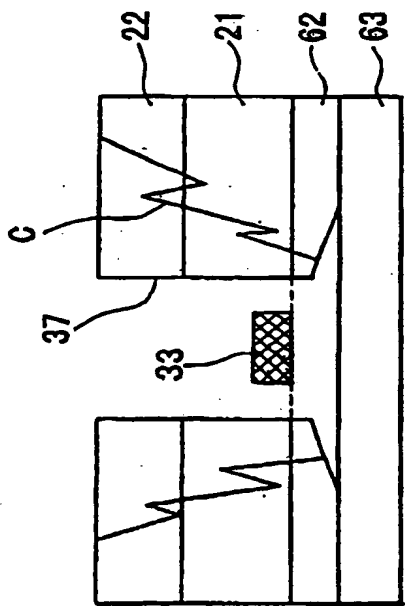
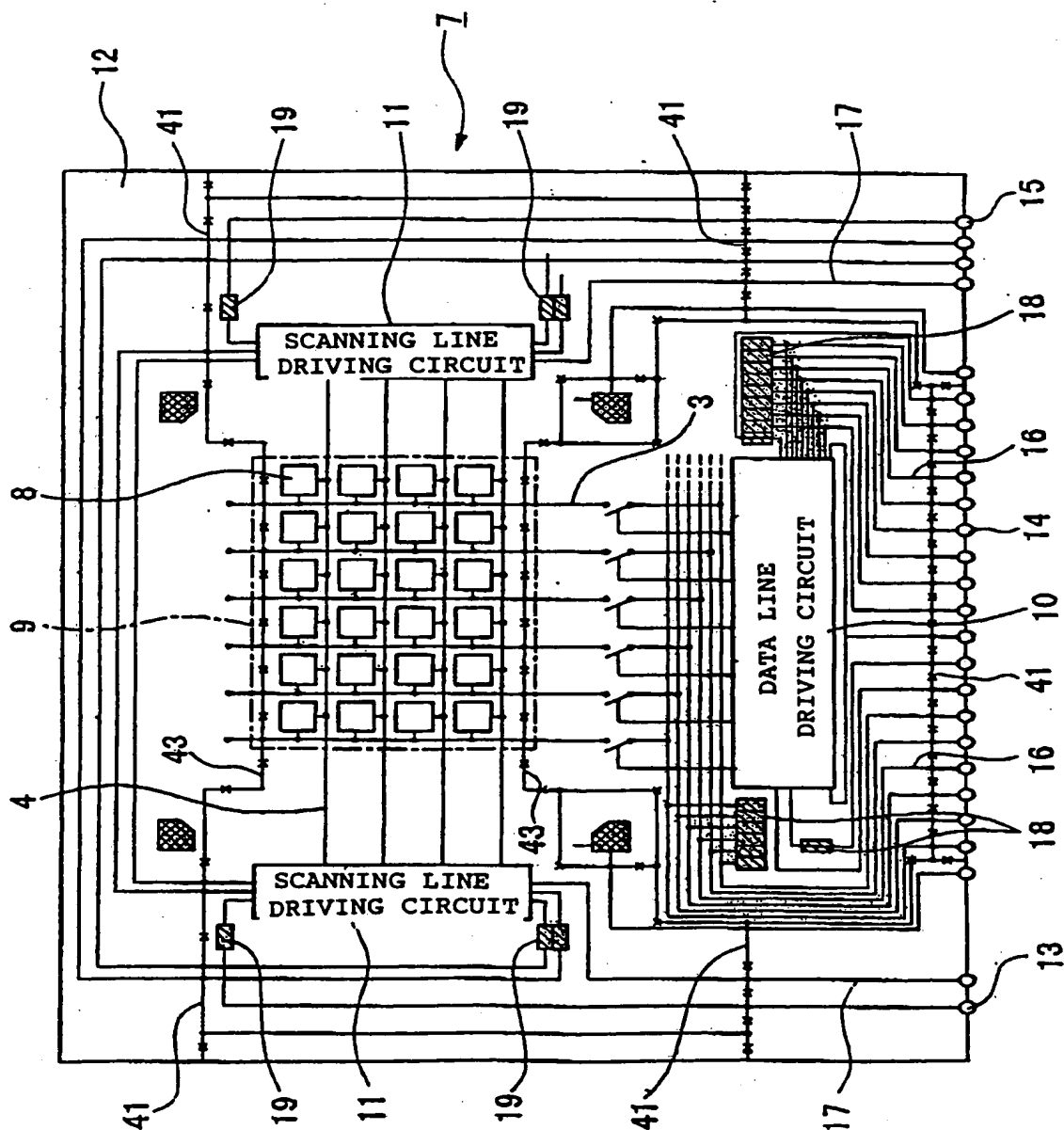
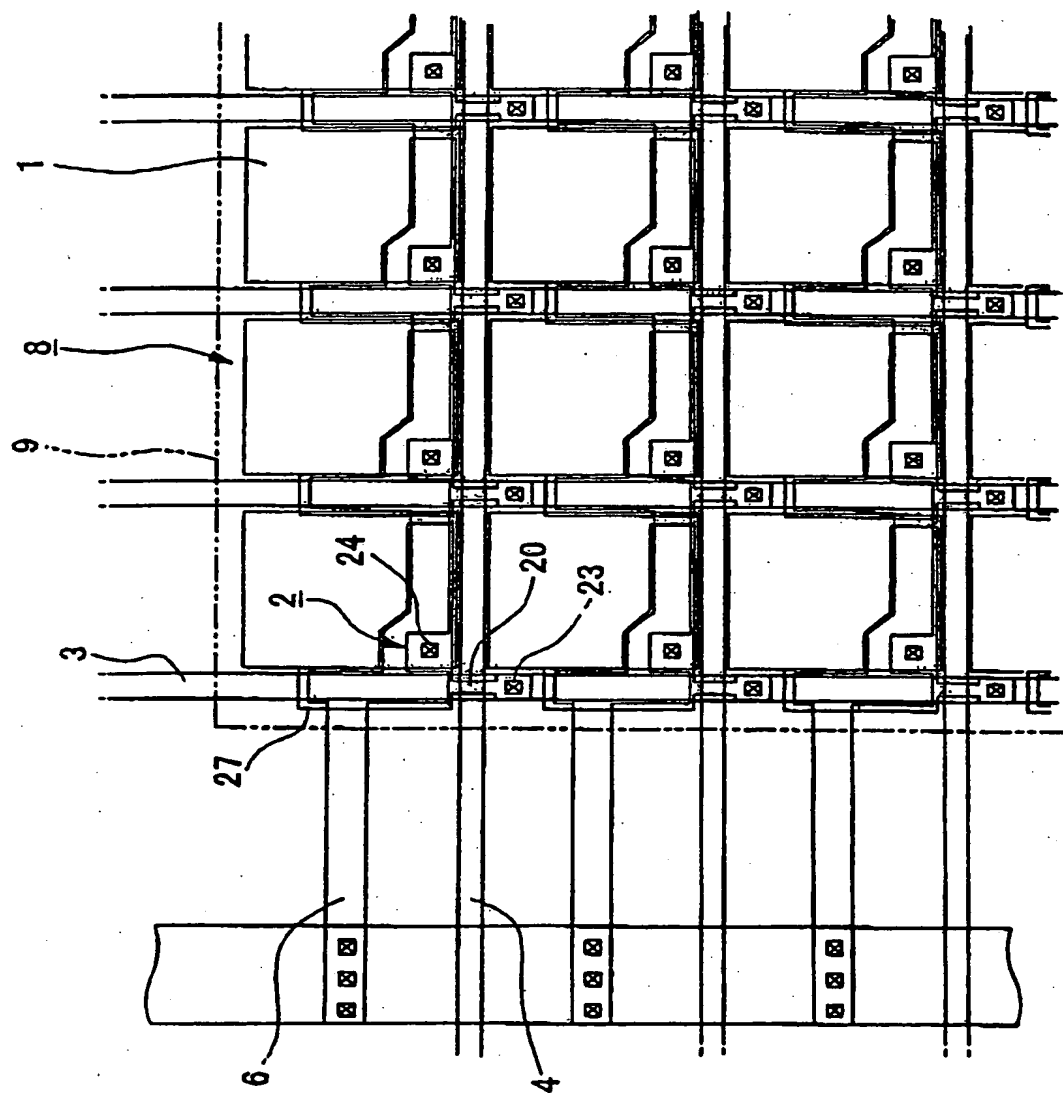


FIG. 26(A)





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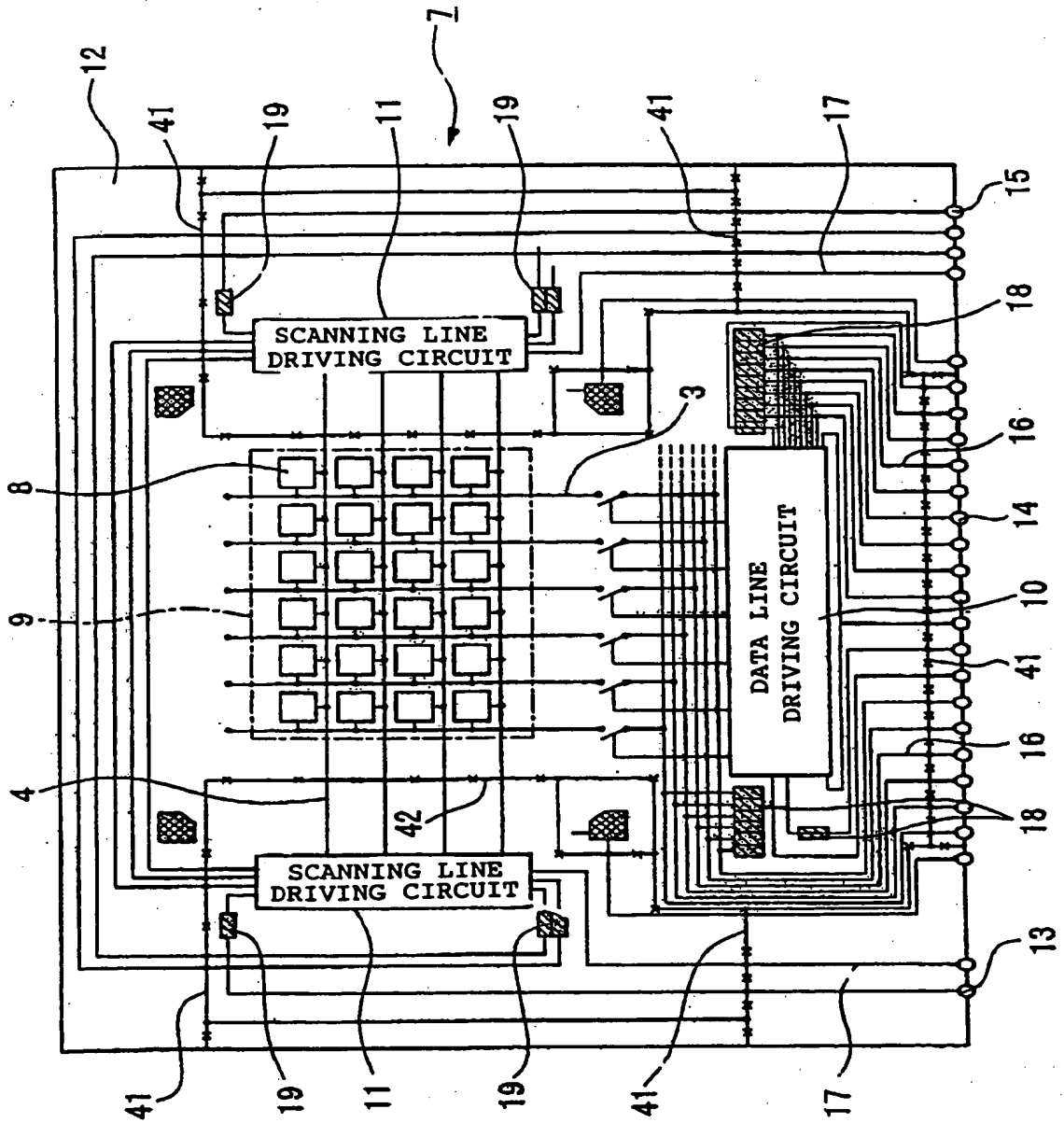


FIG. 29

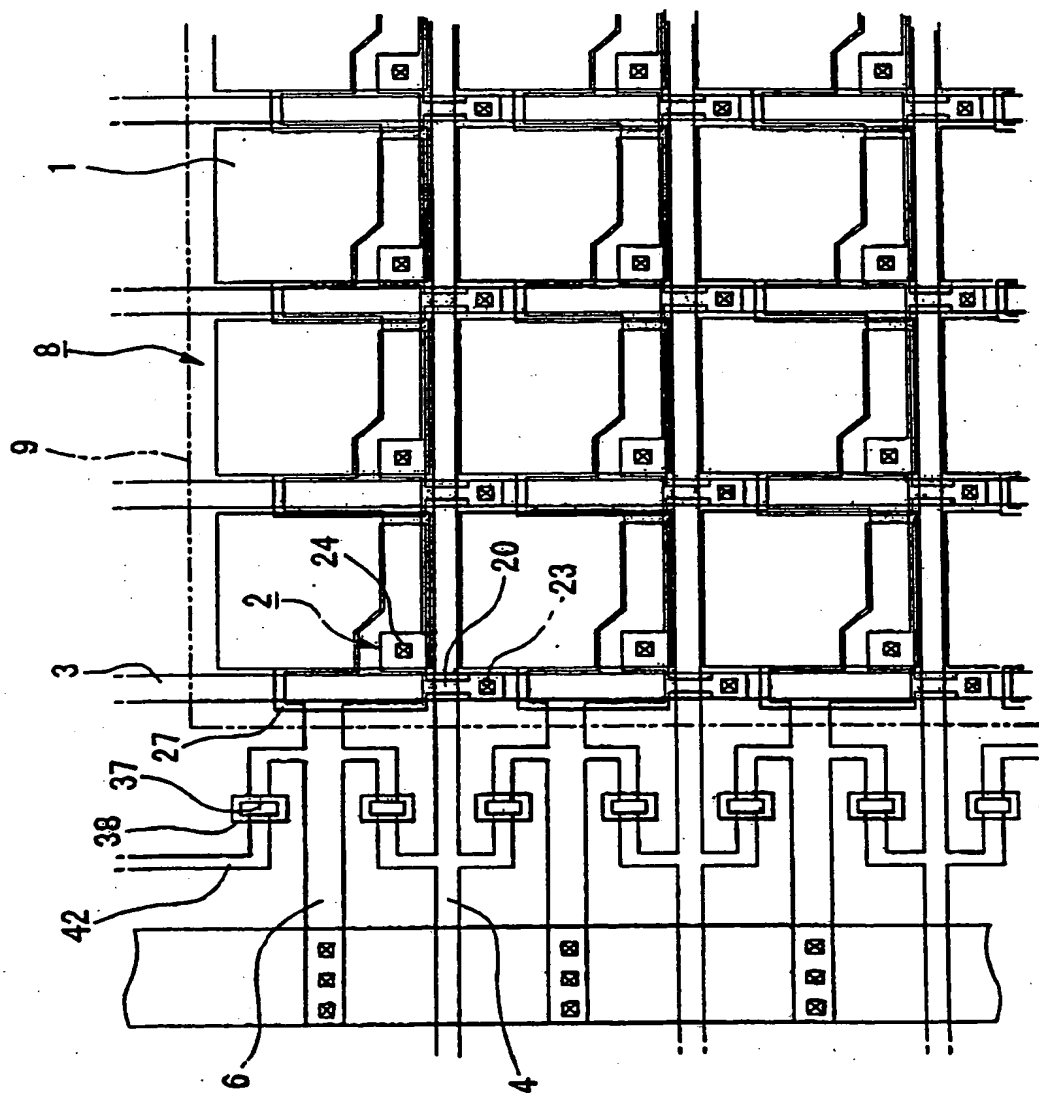


FIG. 36

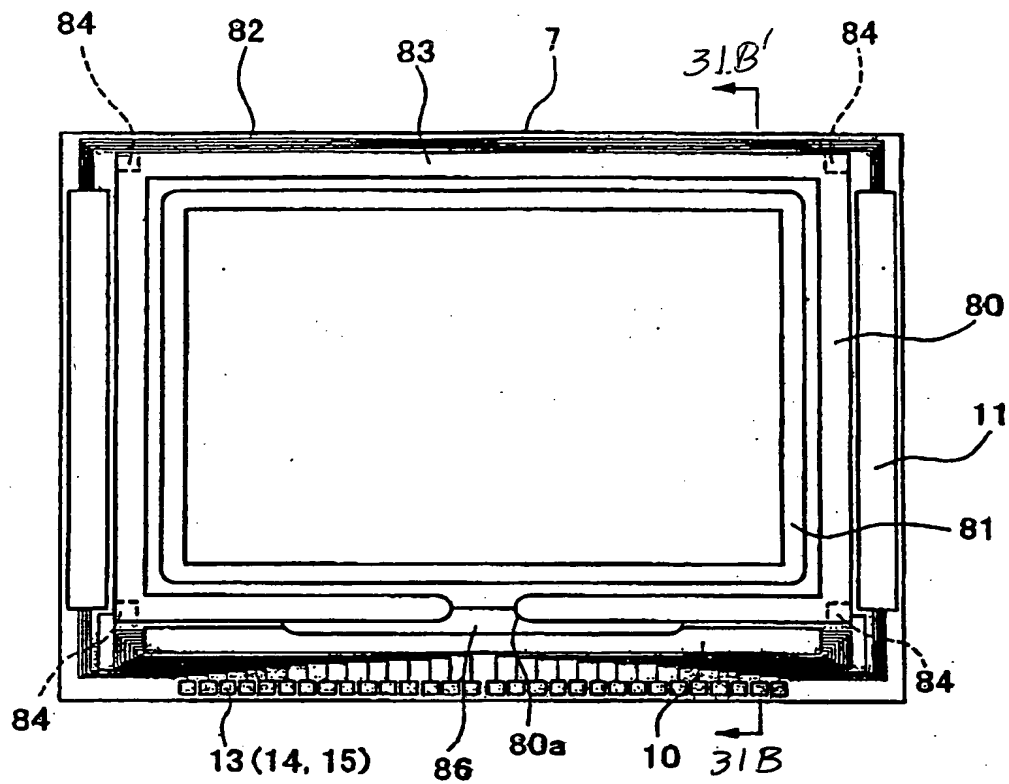


FIG. 31(A)

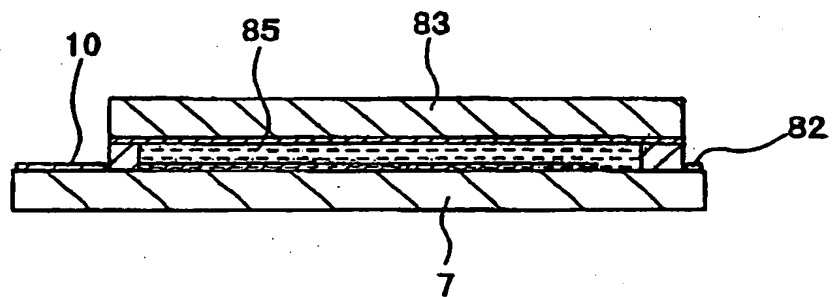


FIG. 31(B)

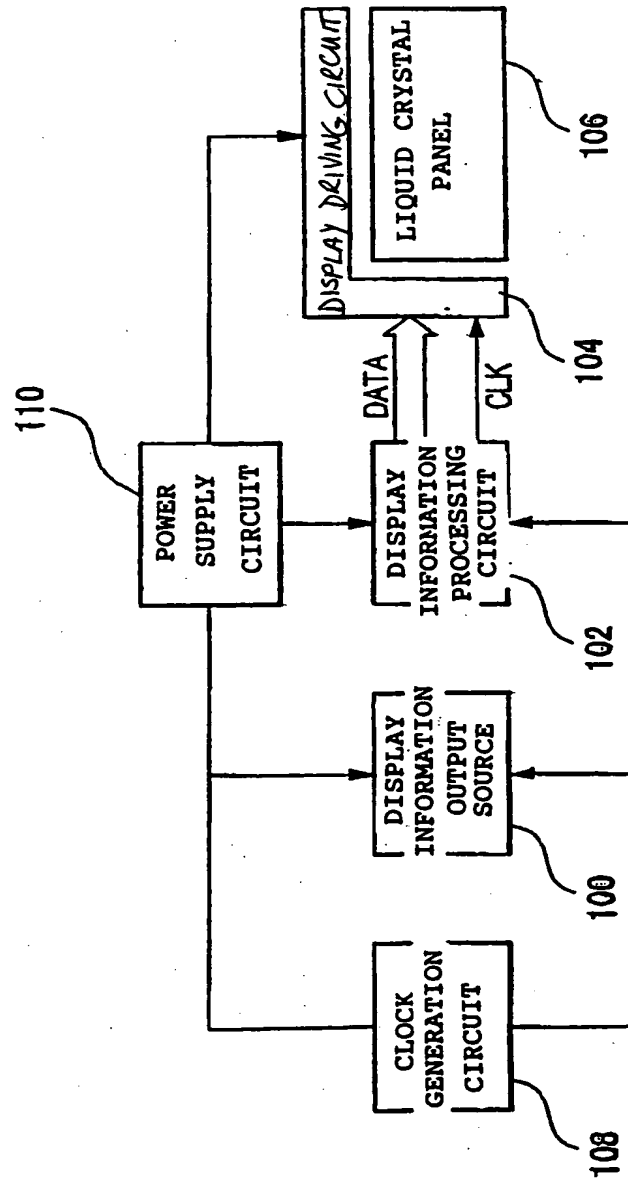


FIG. 32

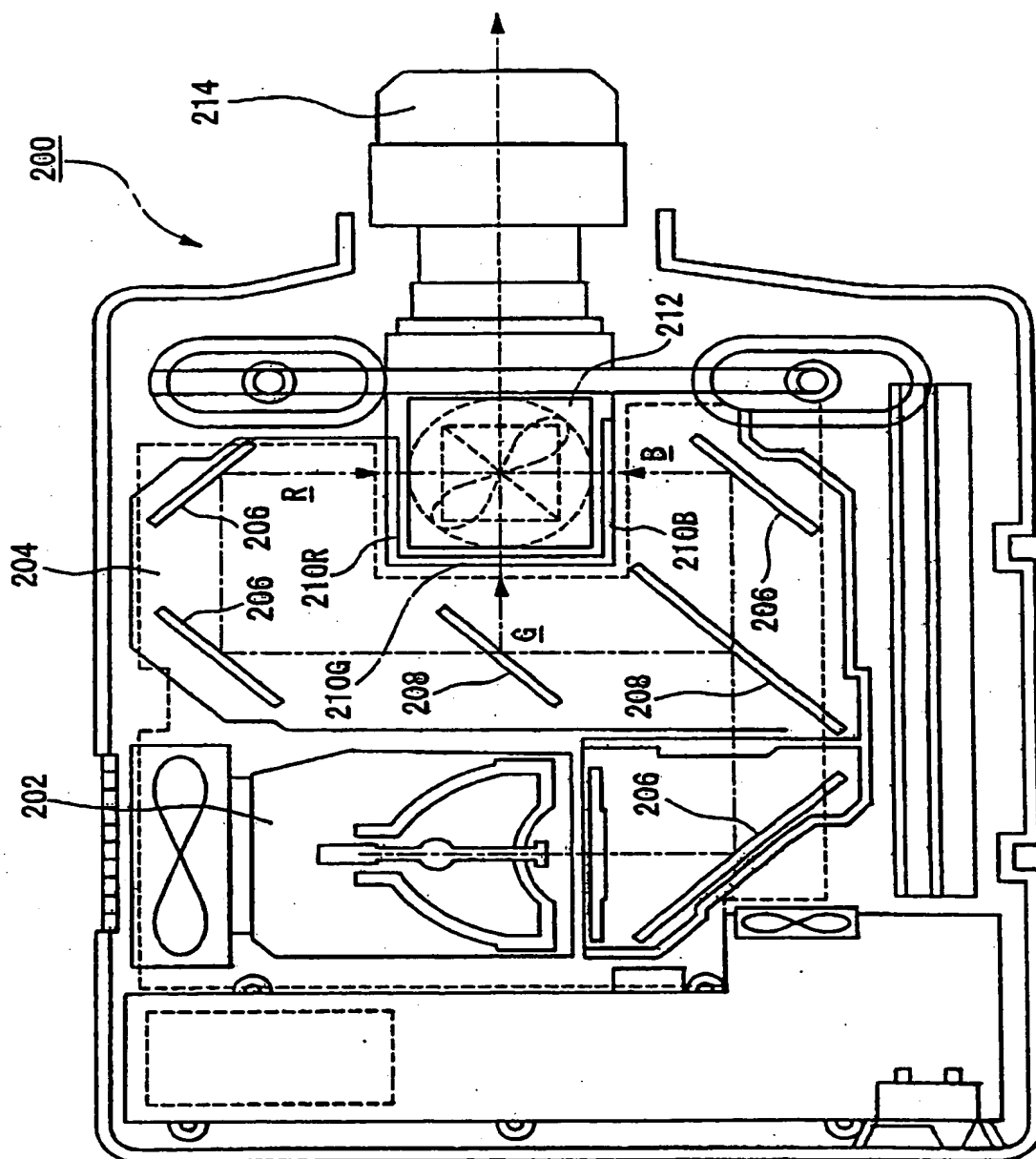


FIG. 33

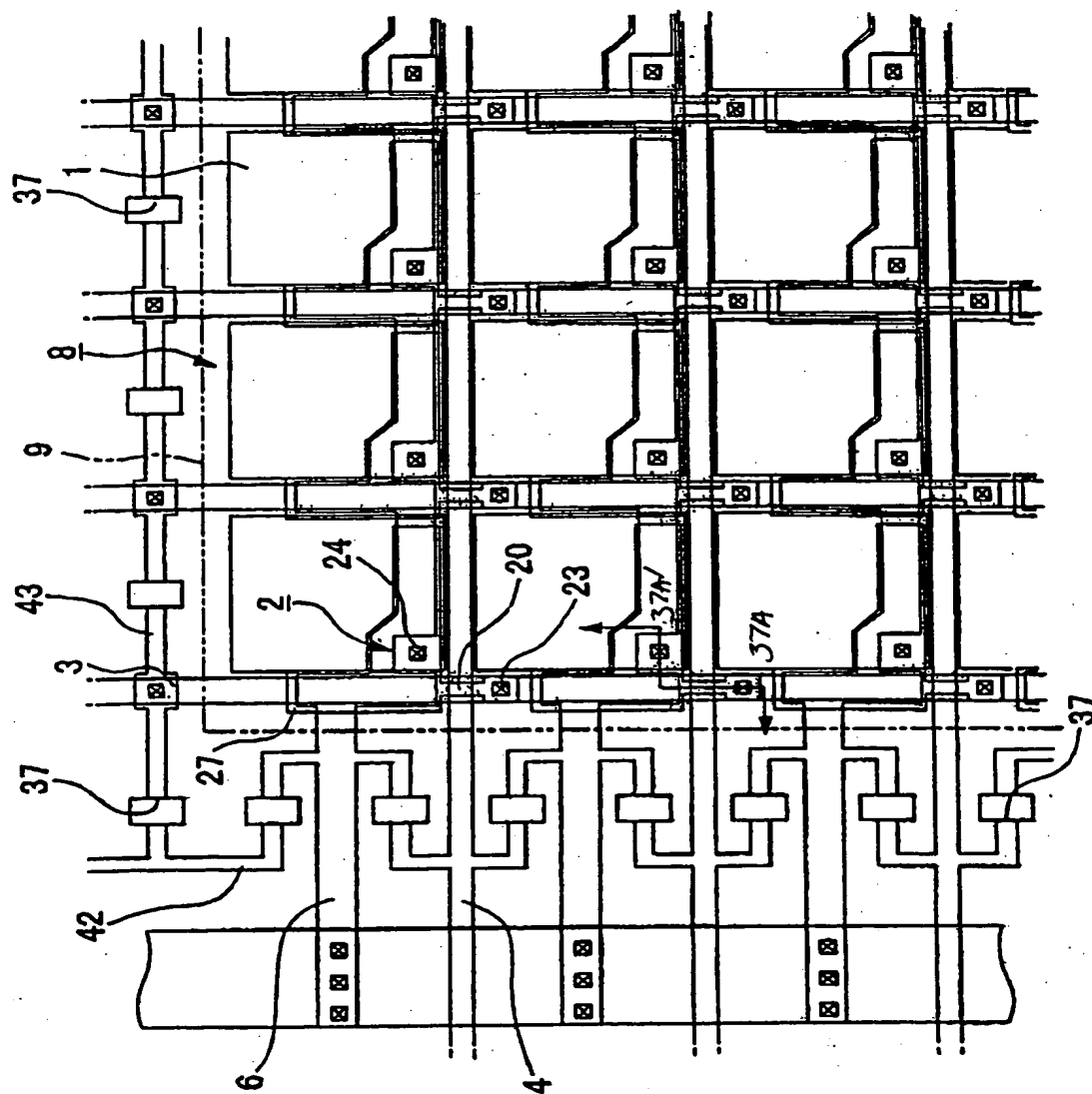


FIG. 34

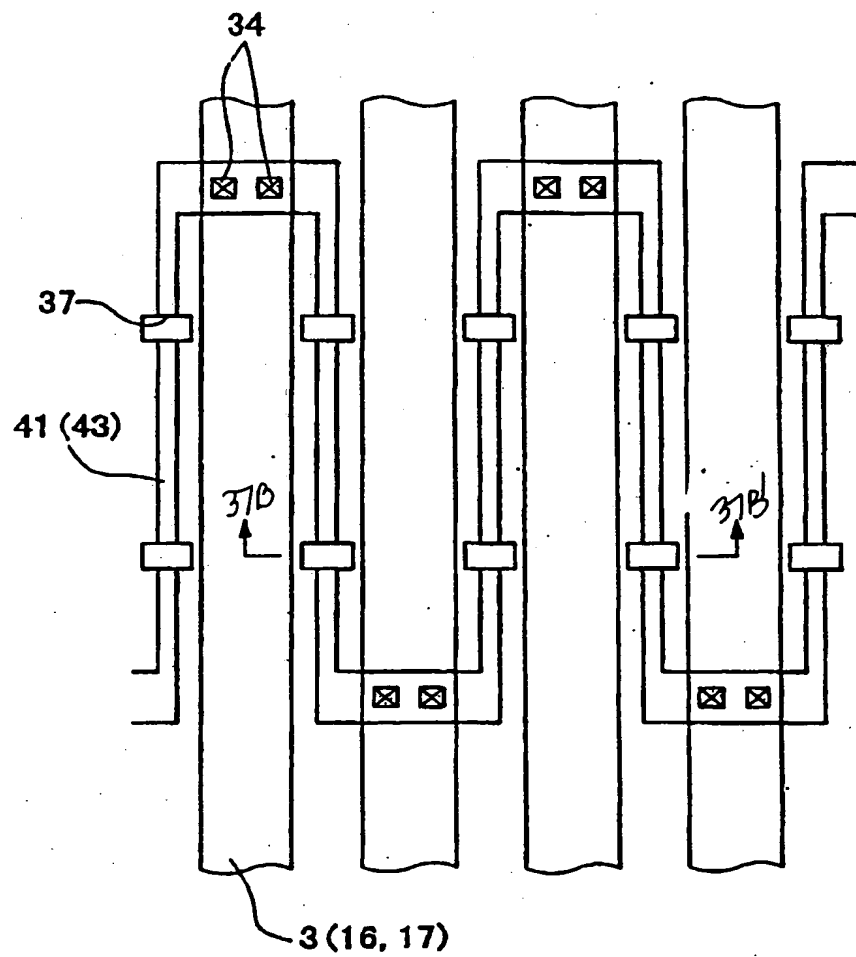
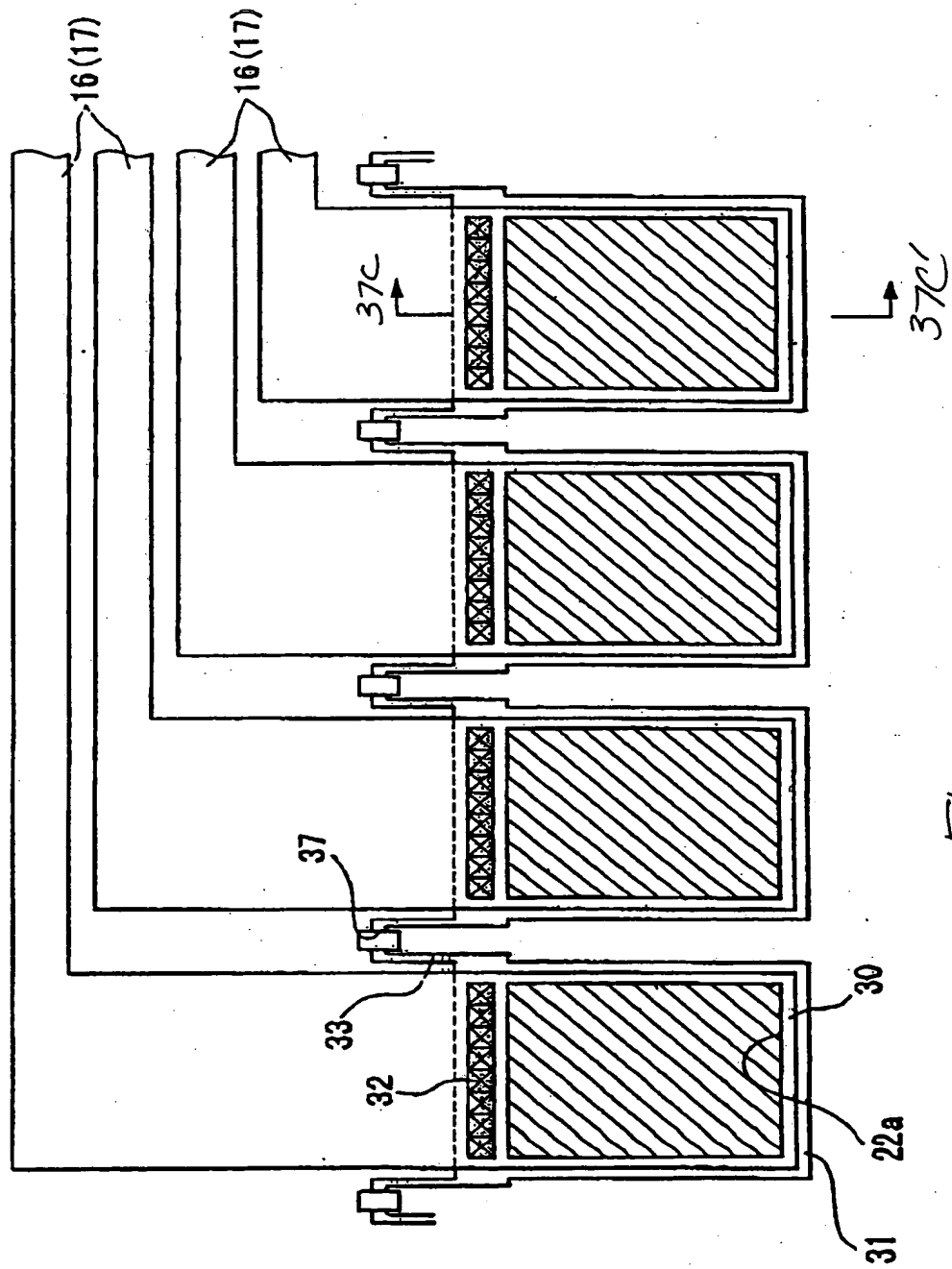


FIG. 35



<PIXEL TFT AREA> <ELECTROSTATIC MEASURE WIRING AREA> <TERMINAL AREA>

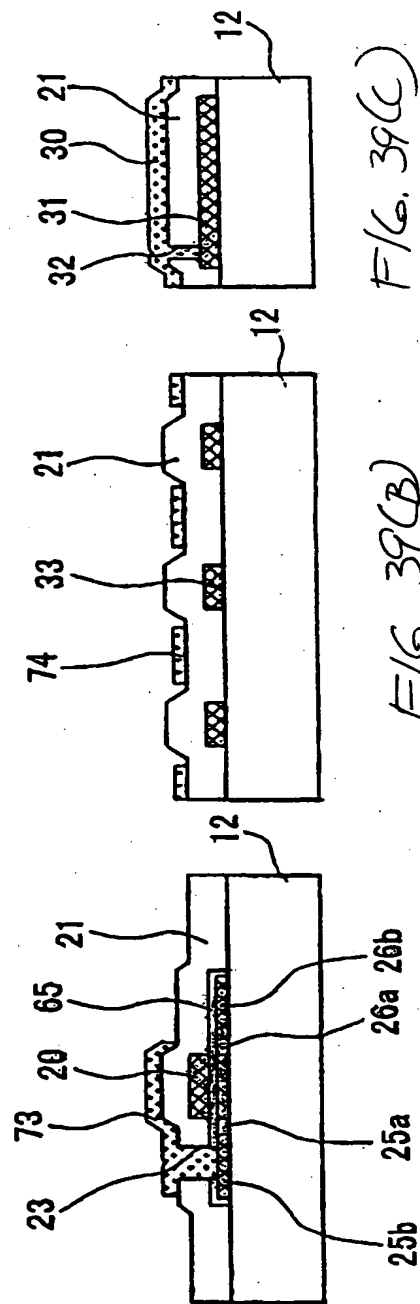
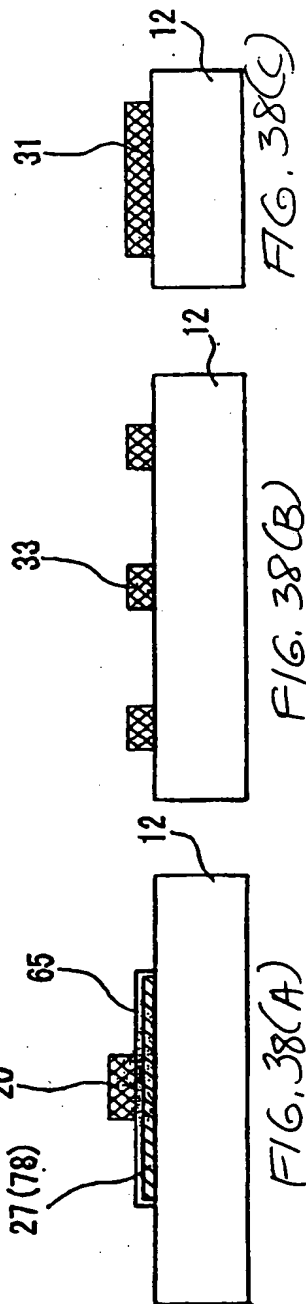
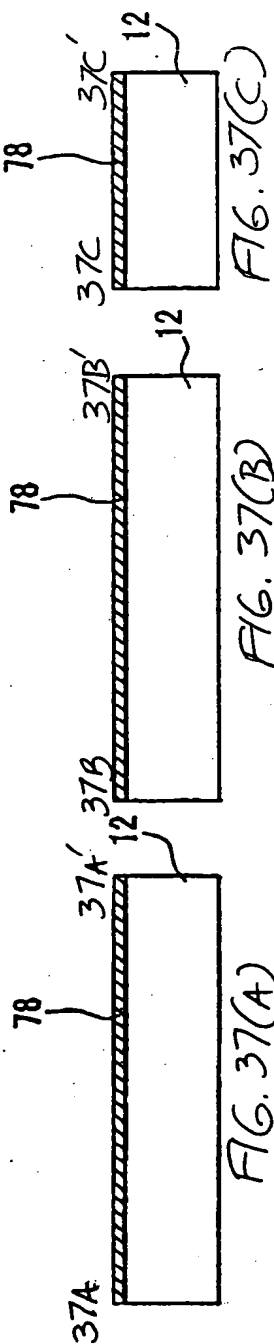


FIG. 39(A)

—
〈PIXEL TFT AREA〉 〈ELECTROSTATIC MEASURE WIRING AREA〉 〈TERMINAL AREA〉

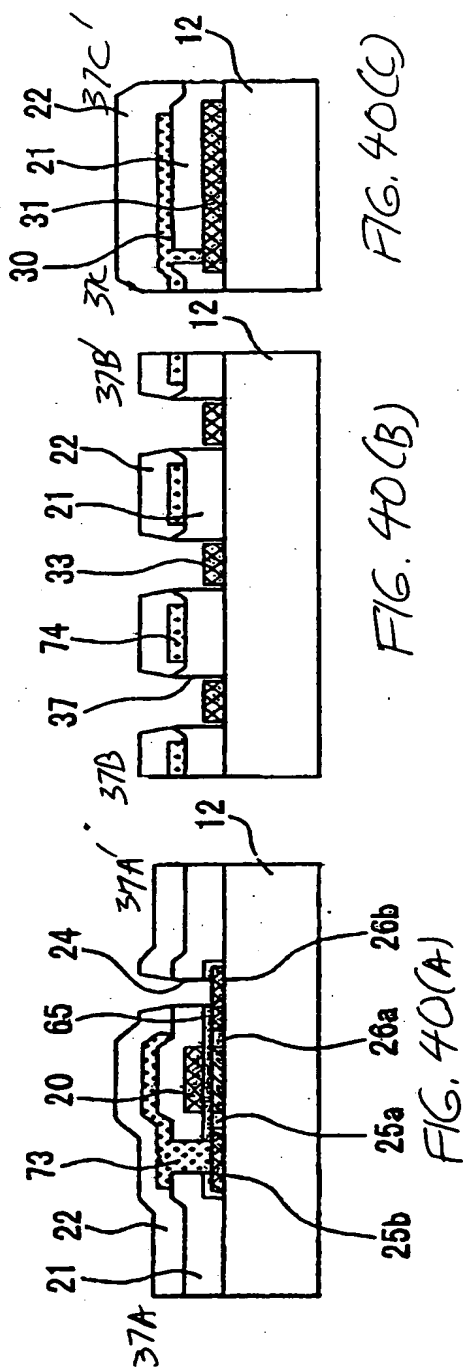


FIG. 40(B)

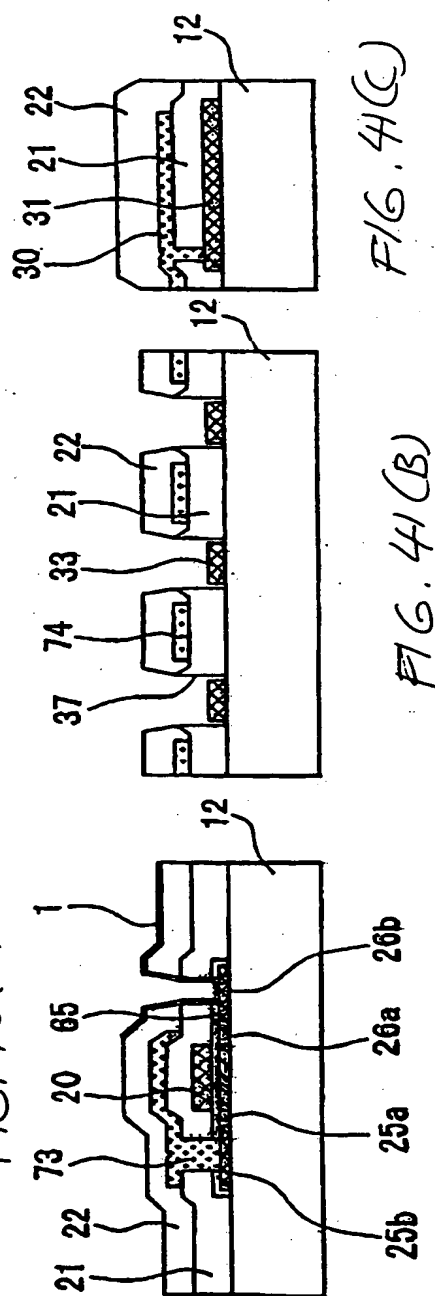
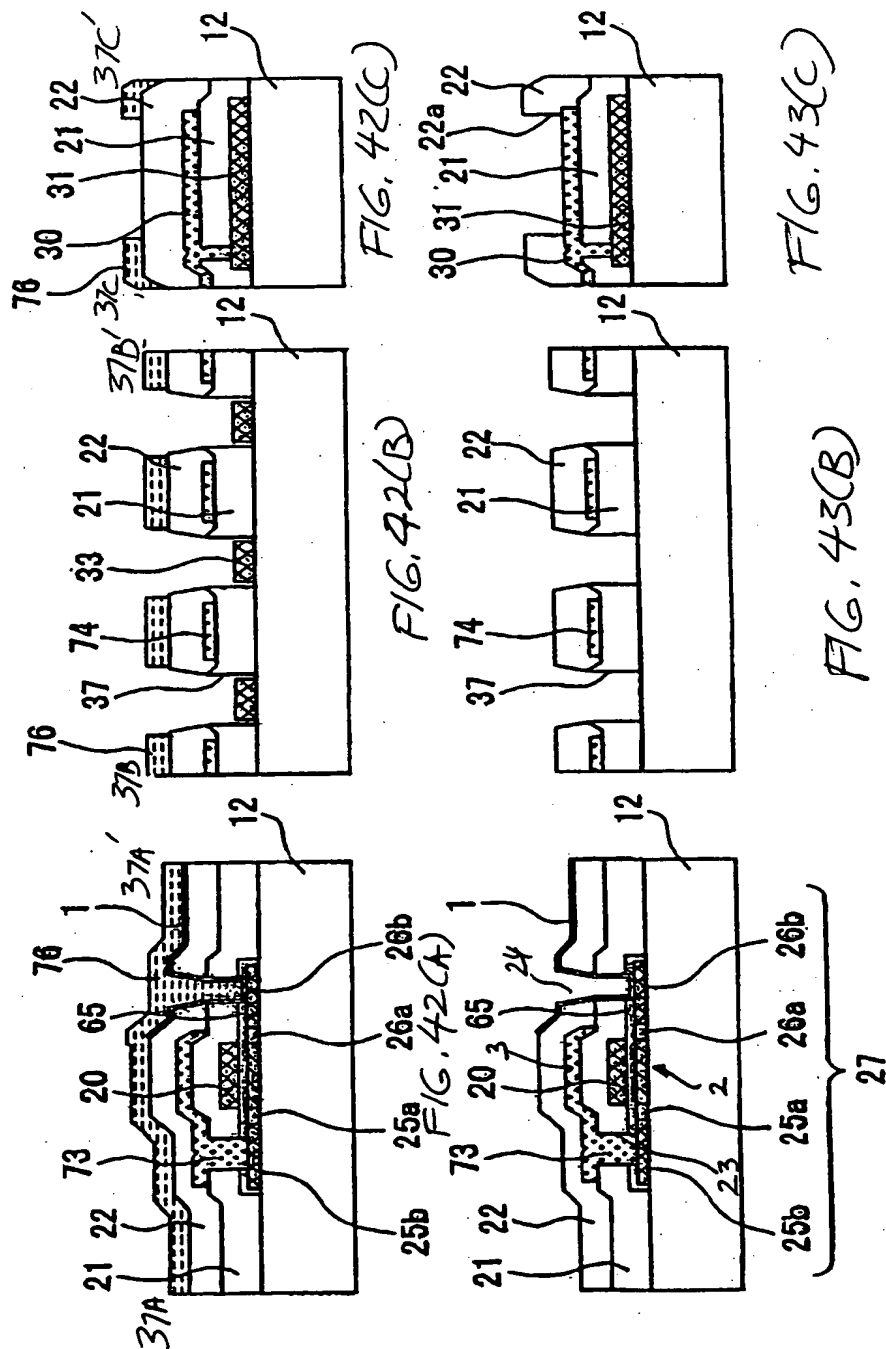


FIG. 41(B)

FIG. 41(A)

<PIXEL TFT AREA>



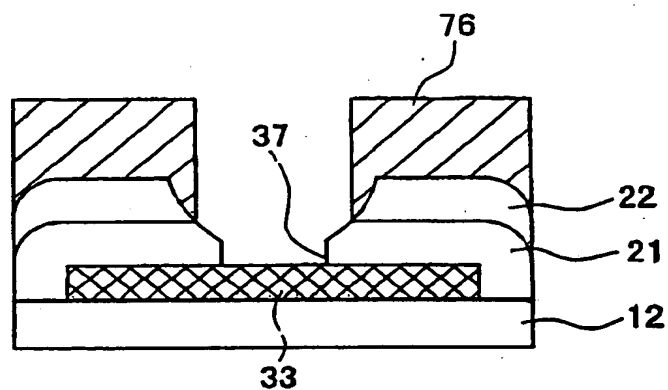


FIG. 44(A)

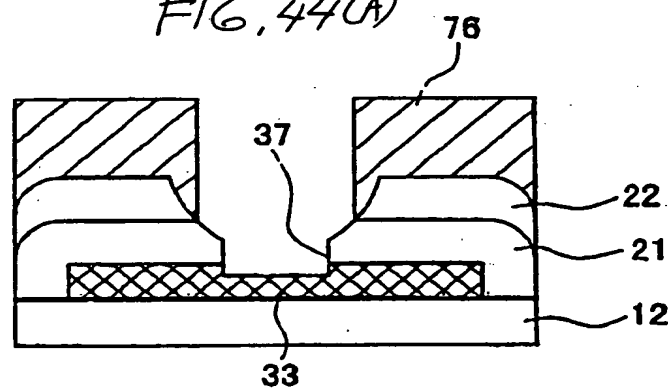


FIG. 44(B)

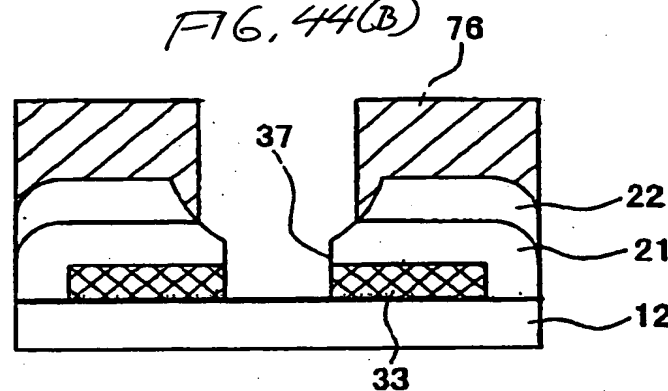


FIG. 44(C)